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Complete if Known

Application Number	Unknown
Filing Date	Herewith
First Named Inventor	Mark A. Lemkin
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	AIMI-01833US0

Sheet 1 of 5

Sheet 1 of 5

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
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		5,506,175		Zhang et al.	04-09-1996	

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Date	
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Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known	
		Application Number	Unknown		
		Filing Date	Herewith		
		First Named Inventor	Mark A. Lemkin		
		Group Art Unit	Unknown		
		Examiner Name	Unknown		
		Attorney Docket Number	AIMI-01833USO		
Sheet	2	of	5		

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		GARY K. FEDDER and TAMAL MUKHERJEE, "Physical Design for Surface-Micromachined MEM Proceedings of the 5th ACM/SIGDA Physical Design Workshop, 4/15-17/1996, pp. 53-60	
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		ROBERT A. CONANT, JOCELYN T. NEE, KAM Y. LAU, RICHARD S. MULLER, "A Flat High-Frequency Scanning Micromirror", 2000 Workshop for Solid State Sensors and Actuators (HH2000), Hilton Head Island, S.C., June 4-8, 2000, pp. 6-9, Digest of Technical Papers	
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		E.K. CHAN and R.W. DUTTON, "Effects of Capacitors, Resistors and Residual Charge on the Static and Dynamic Performance of Electrostatically-Actuated Devices, CISX 305, Center for Integrated Systems, Stanford University, Stanford, CA	
		JOHN H. COMTOIS, M. ADRIAN MICHALICEK, CAROLE CRAIG BARRON, "Fabricating Micro-Instruments in Surface-Micromachined Polycrystalline Silicon", Proceedings of the 43rd Int'l Instrumentation Symposium Instrument Society of America, 1997, pp. 169-179	

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Sheet	4	of	5		

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